among the smallest  $Cu_{2-x}Se$  nanomaterials yet synthesized.

According to the researchers, cubic phase two-dimensional nanomaterials are uncommon, though a significant number occur in wet chemical syntheses. It is thought that these phases are the result of growth kinetics being controlled by ligand interactions with certain crystal planes of the materials as they grow in solution. The researchers said that the NHC products generated after selenium is removed from the precursor molecule play a significant role in forming the discshaped materials, particularly by coordinating copper species on one particular plane forcing continued growth to occur preferentially in the radial direction rather than equally in all directions. Changing the selenium precursor concentration relative to the copper source altered the particle shapes, which varied from a mixture of discs and tetragonal particles to irregular morphology. Using selenium powder instead of the NHC-based precursor formed irregular particles.

Cu<sub>2-x</sub>Se is a *p*-type semiconductor with a 1.0-1.4 eV indirect bandgap, a range suitable for use as an absorbing layer in photovoltaic devices. Based on UV-vis

absorption, the researchers calculate the nanodisc bandgap to be 1.55 eV, an increase attributed to the quantum confinement effect. Photoconductivity measurements as a function of electrical bias on thin films of nanodiscs contacted by silver electrodes on glass substrates show an approximately sixfold increase in current under illumination compared with dark current. This is taken as evidence that the nanodiscs synthesized in this work may be incorporated into solar cells through solution-based processing.

ALIA P. SCHOEN

## White Light Illumination Produces Tunable Color from Silicon Nanostructures

Silicon is widely used in the microelectronics industry due to its electronic characteristics. On the other hand, the use of Si for optical applications requiring emission of light has been limited by the fact that silicon has an indirect bandgap, which results in poor light emission. Researchers have somewhat overcome these limitations by leveraging the impressive nanofabrication capabilities that exist for Si to produce structures capable of light emission, optical cloaking, waveguiding, and sensing.

Recently, L. Cao and colleagues from the Geballe Laboratory for Advanced Materials at Stanford University have exploited the resonant light scattering properties of Si nanostructures to produce silicon nanowires (SiNWs) and nanoparticles (SiNPs) with engineered color. In the July 14th issue of Nano Letters (DOI: 10.1021/nl1013794; p. 2649), the team described the white light illumination (polarized and unpolarized) of SiNWs under grazing incidence using a confocal, darkfield optical microscope. The group led by M.L. Brongersma grew SiNWs using a gold colloid-catalyzed chemical vapor deposition process which allowed for accurate diameter control and precise elucidation of the relation-

## 5<u>0 μm</u>

Figure 1. Darkfield optical image of a large-scale patterned Si nanowire (SiNW) array. The array was fabricated using standard polycrystalline silicon thin-film deposition, lithographic patterning, and dry etching. The pattern consists of four types of arrays with distinct NW widths: 170 nm (blue), 200 nm (green), 240 nm (yellow), and 300 nm (red). The NW lengths (10  $\mu$ m) were chosen to be much longer than the width. Their height was set by the deposited film thickness of 180 nm. The interspacing between NWs was 130 nm. Credit Pengyu Fan

ship between NW size and resonant light scattering. The researchers observed a continuous change in SiNW color across the entire visible spectrum under randomly polarized white light illumination, with color shifting linearly from blue to red with increasing wire diameter. Similarly, they observed size-dependent color in large-scale, sub-wavelength SiNW and SiNP arrays (Figure 1) which were generated with carefully selected physical dimensions using standard polycrystalline Si thin-film deposition, lithographic patterning, and dry etching.

The Stanford team noted that color also varied with the polarization state of the illumination source and related this polarization dependence, as well as the size dependence, to the well-known Lorentz-Mie theory of light scattering. They also described the sensitivity of SiNW light scattering to their surrounding dielectric environment, which is related to the "leaky" nature of NW modes whose fields extend outside of the NWs. The ability to engineer color in Si nanostructures by strategic selection of size, dielectric environment, and illumination conditions greatly increases its potential application for information, display, camouflage, ornamental, and biotechnologies.

"Si is expected to further solidify its dominance in an increasing number of high-volume technologies," said Cao, when considering these new findings in conjunction with Si's excellent electrical, mechanical, and biochemical properties. "This puts this material in a new light."

SAMESHA R. BARNES

## Stagnation Mechanism Revealed in Simulations of Grain-Boundary Roughening in Nickel at High Temperatures

Grain growth in polycrystalline materials almost always stops well before the equilibrium state of single crystal is reached. Conventional mechanisms for grain-growth stagnation include solute segregation to grain boundaries and pinning of grain boundaries by second phase particles. However, grain-growth stagnation is also observed in materials where such mechanisms are not applicable, as in high purity materials, and materials with high solute diffusivity. In order to expand understanding of the mechanisms hindering grain growth, E.A. Holm and S.M. Foiles from Sandia National Laboratories applied computational models to simulate grain growth in pure nickel. Their results suggested an alternative mechanism, which they described in the May 28th issue of *Science* (DOI: 10.1126/science.1187833; p. 1138).

The researchers used a synthetic-driving force molecular dynamics method (MD) to calculate grain boundary mobility for a